

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Volker Härle et al. Art Unit : 2892
Serial No. : 10/813,530 Examiner : Chuong A. Luu
Filed : March 29, 2004 Conf. No. : 5329
Title : METHOD FOR FABRICATING A SEMICONDUCTOR COMPONENT BASED
ON A NITRIDE COMPOUND SEMICONDUCTOR

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF JUNE 26, 2008

Please amend the above-identified application as follows: